


Search Notes 	Application/Control No. 10711416	Applicant(s)/Patent Under Reexamination DORIS ET AL.
	Examiner Wai-Sing Louie	Art Unit 2814

SEARCHED			
Class	Subclass	Date	Examiner
438	164	9/21/06	MDH
257	335	9/21/06	MDH
257	67, 347, 351	12/18/07	WSL
438	149,154,157	12/18/07	WSL

SEARCH NOTES		
Search Notes	Date	Examiner
wafer bonding, through hole, epitaxial growth, crystal orientation, buried oxide layer, oxygen implanting, annealing	12/18/07	WSL

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
438	149,154,157	12/18/07	WSL